L Number	Hits	Search Text	DB	Time stamp
-	109	The state of the s	USPAT;	2003/11/17 17:40
1		electrode\$1).clm.	US-PGPUB;	
			EPO; JPO;	
i			DERWENT;	
	44	piezoelectric and ((top and bottom) adj	IBM_TDB	0000/11/17 17 17
	7.3	electrode\$1) and taper\$4	USPAT; US-PGPUB;	2003/11/17 17:47
		orocciodetry and capery	EPO; JPO;	
			DERWENT;	
			IBM TDB	
-	603	The state of the s	USPĀT;	2003/11/17 16:47
		electrode\$1)	US-PGPUB;	-
İ			EPO; JPO;	
	}		DERWENT;	
	4507	(Al or aluminum) and taper\$4 and (Ti or	IBM TDB USPAT;	2003/11/17 16:25
		titanium) and etch\$3 and (mask\$3 or	US-PGPUB;	2003/11/1/ 18:23
1		\$5resist)	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
~	2895	1 ,	USPAT;	2003/11/17 16:24
		titanium) and etch\$3 and (mask\$3 or \$5resist) and electrod\$2	US-PGPUB;	
]		Angeler and elections	EPO; JPO; DERWENT;	
			IBM TDB	
~	823	1 () () () () () () () () () (USPAT;	2003/11/19 15:32
		titanium) and (etch\$3 adj rate\$1) and	US-PGPUB;	
		(mask\$3 or \$5resist) and electrod\$2	EPO; JPO;	
			DERWENT;	
	21		IBM_TDB	
	2.1	((Al or aluminum) and taper\$4 and (Ti or titanium) and etch\$3 and (mask\$3 or	USPAT;	2003/11/17 16:26
		\$5resist)).ab.	US-PGPUB; EPO; JPO;	!
		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	DERWENT;	
			IBM TDB	
-	193		USPĀT;	2003/11/17 16:27
		electrode\$1) and taper\$4	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
	404	(aluminum with taper\$2) and etch\$3	IBM_TDB USPAT;	2003/11/17 16:48
		(*************************************	US-PGPUB;	2003/11/1/ 10:40
			EPO; JPO;	
			DERWENT;	
	004	(alamaha a daya daya daya	IBM_TDB	
_	224	(aluminum with taper\$2) same etch\$3	USPAT;	2003/11/17 16:48
ļ			US-PGPUB;	
j	į		EPO; JPO; DERWENT;	
			IBM TDB	
-		1151236.URPN.	USPAT	2003/11/17 16:56
-	9	((Al or aluminum) and taper\$4 and (Ti or	USPAT;	2003/11/17 16:57
		titanium) and (etch\$3 adj rate\$1) and	US-PGPUB;	
	Ì	(mask\$3 or \$5resist)).clm.	EPO; JPO;	
	İ		DERWENT;	
	11	5464500.URPN.	IBM_TDB USPAT	2003/11/17 16:59
_		("3700508" "3825454" "4610502"	USPAT	2003/11/17 16:59 2003/11/17 17:00
		"5007984" "5118385").PN.		
-	5	("3700508" "3825454" "4610502"	USPAT	2003/11/17 17:05
	_ ["5007984" "5118385").PN.		
		5464500.URPN.	USPAT	2003/11/17 17:05
_	4 /	((Al or aluminum) and taper\$4 and (Ti or titanium) and etch\$3 and (mask\$3 or	USPAT;	2003/11/17 17:07
1		\$5resist)).clm.	US-PGPUB;	
İ			EPO; JPO; DERWENT;	
			IBM TDB	
			<u> </u>	

-	2	ALCCACOCOUN DN	የችላ እንዳ ለ ን .	1 9000 /11 /17 17.16
	۷ ا	("5575962").PN.	USPAT;	2003/11/17 17:15
			US-PGPUB; EPO; JPO;	
			DERWENT;	
			IBM TDB	
_	456	(438/738).CCLS.	USPAT;	2003/11/17 17:37
			US-PGPUB;	
			EPO; JPO;	
1			DERWENT;	ļ
	424	///20/720\ GGT G \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \	IBM_TDB USPAT;	2003/11/17 17:34
-	174	((438/738).CCLS.) and (al or aluminum) and (ti or titanium)	US-PGPUB;	2003/11/1/ 1/:34
		(CI OI CICANIUM)	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
-	23	((438/738).CCLS.) and (al or aluminum) and	USPAT;	2003/11/17 17:36
		(ti or titanium) and taper\$2	US-PGPUB;	
			EPO; JPO; DERWENT;	
			IBM TDB	
_	134	(216/95).CCLS.	USPAT;	2003/11/17 17:36
	101	(2107 557 · 00Db ·	US-PGPUB;]
			EPO; JPO;	
			DERWENT;	
	_	. (04.6 (05) - 05.6)	IBM_TDB	0000/11/10 10 00
-	3	((216/95).CCLS.) and (all or aluminum) and	USPĀT; US-PGPUB;	2003/11/17 17:36
		(ti or titanium) and taper\$2	EPO; JPO;	
			DERWENT;	
			IBM TDB	
	178	(438/735).CCLS.	; TAGSU	2003/11/17 17:37
			US-PGPUB;	
			EPO; JPO;	
			DERWENT;	Ì
	141	(438/736).CCLS.	IBM_TDB USPAT;	2003/11/17 17:38
	141	(43077307.0020.	US-PGPUB;	2003/11/1/ 1/:00
1			EPO; JPO;	1
			DERWENT;	
			IBM_TDB	
-	121	(438/737).CCLS.	USPĀT; US-PGPUB;	2003/11/17 17:38
			EPO; JPO;	
			DERWENT;	
	Ì		IBM TDB	
_	201	(438/739).CCLS.	USPAT;	2003/11/17 17:38
	j		US-PGPUB;	
	İ		EPO; JPO;	
1	ļ		DERWENT; IBM TDB	
_	219	(438/742).CCLS.	USPAT;	2003/11/17 17:38
	213	(100) (12) . 0000.	US-PGPUB;	= = = = = = = = = = = = = = = = = = =
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	0000 /45 /45 45 55
-	754	(216/2).CCLS.	USPAT;	2003/11/17 17:38
	į		US-PGPUB; EPO; JPO;	
1	ļ		DERWENT;	
	:		IBM TDB	
-	1106	(216/13).CCLS.	USPĀT;	2003/11/17 17:39
	j		US-PGPUB;	
	Ì		EPO; JPO;	
			DERWENT; IBM TDB	[
_	115	(216/32).CCLS.	USPAT;	2003/11/17 17:39
	110	\2.50\ 02\0010\.	US-PGPUB;	2003/11/1/ 1/103
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	

		· · · · · · · · · · · · · · · · · · ·		
_	1063	(216/41).CCLS.	USPAT;	2003/11/17 17:39
			US-PGPUB;	Ì
1	ļ		EPO; JPO;	<u>L</u>
			DERWENT;	
			IBM TDB	
_	75	piezoelectric and aluminum and ((top and	USPAT;	2003/11/17 17:40
		bottom) adj electrode\$1).clm.	US-PGPUB;	1
		boccom, and crossroned 1, crim.	EPO; JPO;	
	Į.		DERWENT;	
1			1	,
			IBM_TDB	0000/11/15 15 10
-	143	,	USPAT;	2003/11/17 17:42
	į	electrode\$1) and taper\$4	US-PGPUB;	Į.
			EPO; JPO;	
	j		DERWENT;	İ
1			IBM TDB	
-	1066	piezoelectric and aluminum and electrode\$1	USPAT;	2003/11/17 17:52
	İ	and taper\$4	US-PGPUB;	
			EPO; JPO;	
1	}		DERWENT;	\$
	İ		IBM TDB	
	4	/mis-salantuia and aluminum and	USPAT;	2003/11/17 17:49
[-	4	1 12 - 4 - 4 - 4 - 4 - 4 - 4 - 4 - 4 - 4 -	•	2003/11/1/ 17:49
1	İ	electrode\$1 and taper\$4).clm.	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
}			IBM_TDB	1
-	27	(piezoelectric and aluminum and	USPĀT;	2003/11/17 17:51
		electrode\$1).clm. and taper\$4	US-PGPUB;	
,	Į.		EPO; JPO;	1
			DERWENT;	
			IBM TDB	
	725	mineral nature and aluminum and aleatmedact		2002/11/17 17.50
<u> </u>	735	↓ →	USPĀT;	2003/11/17 17:58
		and (resonator\$3 or transducer\$1).ti.	US-PGPUB;	1
	}		EPO; JPO;	
1	1		DERWENT;	\
			IBM TDB	1
-	4	(piezoelectric and aluminum and	USPAT;	2003/11/17 18:00
	1	electrode\$1 and taper\$3).clm.	US-PGPUB;	į.
			EPO; JPO;	
			DERWENT;	
			IBM TDB	1
_	356	(piezoelectric and aluminum and	USPAT;	2003/11/17 18:01
Ì	330	electrode\$1).clm.	US-PGPUB;	2003/11/1/ 10:01
		electiodesi, cim.		1
			EPO; JPO;	1
			DERWENT;	
İ			IBM_TDB	İ
-	1045	(aluminum and ((aluminum adj nitride) or	USPAT;	2003/11/17 18:02
		(zinc adj oxide)) and electrode\$1).clm.	US-PGPUB;	1
			EPO; JPO;	1
			DERWENT;	
1			IBM TDB	
-	14	(aluminum and taper\$3 and ((aluminum adj	USPAT;	2003/11/17 18:04
		nitride) or (zinc adj oxide)) and	US-PGPUB;	
	}	electrode\$1).clm.	EPO; JPO;	1
		erectoredit.cim.		
			DERWENT;	1
(IBM_TDB	
-	120	1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	USPAT;	2003/11/17 18:09
]	adj nitride) or (zinc adj oxide)) and	US-PGPUB;	1
] .	Į	electrode\$1).clm.	EPO; JPO;	
])		DERWENT;]
Ì	!		IBM TDB	1
! i	17	((thin adj film adj resonator) or TFR).ab.	USPAT;	2003/11/17 18:11
}	1 - '	and (aluminum and ((aluminum adj nitride)	US-PGPUB;	
	ļ	or (zinc adj oxide)) and electrode\$1)	EPO; JPO;	
]		or (sinc ad) oxide// and electrodes1)		1
[Į i		DERWENT;	1
			IBM_TDB	
_	157	((thin adj film adj resonator) or TFR).ti.	USPĀT;	2003/11/17 18:11
]		US-PGPUB;	
1	<u> </u>		EPO; JPO;	<u>'</u>
1			DERWENT;	
<u> </u>	į l		IBM TDB	
<u> </u>	•		<u>====</u>	·

_	166	(())	USPAT;	2003/11/17 18:29
		TFR).ti.	US-PGPUB; EPO; JPO;	
			DERWENT;	
_	40	((thin adj film adj resonator\$1) or TFR)	IBM_TDB USPAT;	2003/11/17 18:19
		and taper\$3	US-PGPUB;	2003/11/1/ 10:19
	<u> </u>		EPO; JPO; DERWENT;	
			IBM TDB	
-	26	((thin adj film adj resonator\$1) or TFR).ti.	USPAT; US-PGPUB	2003/11/17 18:26
-	41	(bulk adj acoustic adj resonator\$1).ti.	USPAT; US-PGPUB	2003/11/17 18:26
-	241	((thin adj film adj resonator\$1) or TFR).ab.	USPAT;	2003/11/17 18:31
		iii, ab.	US-PGPUB; EPO; JPO;	
:			DERWENT; IBM TDB	
	118	i a contract of the contract o	USPAT;	2003/11/17 18:41
		(taper\$3 near2 electrode\$1)	US-PGPUB; EPO; JPO;	
			DERWENT;	
_	206	(TFT) and (taper\$3 near2 electrode\$1)	IBM_TDB USPAT;	2003/11/17 18:43
		(all the company of mounts of occupants)	US-PGPUB;	2003/11/17 10:43
			EPO; JPO; DERWENT;	
	0.27	(7777)	IBM_TDB	
-	237	(TFT) and (taper\$3 with electrode\$1) and ((zinc adj oxide) or (aluminum adj	USPAT; US-PGPUB;	2003/11/17 18:46
		nitride))	EPO; JPO;	
			DERWENT; IBM TDB	
-	225	(TFT) and aluminum and (taper\$3 with electrode\$1) and ((zinc adj oxide) or	USPĀT;	2003/11/17 18:57
		(aluminum adj nitride))	US-PGPUB; EPO; JPO;	
			DERWENT;	
_	186	· · · · · · · · · · · · · · · · · · ·	IBM_TDB USPAT;	2003/11/17 19:01
	}	(film adj resonator\$1)) and ((zinc adj oxide) or (aluminum adj nitride) or AlN or	US-PGPUB; EPO; JPO;	
		ZnO)	DERWENT;	
-	192	((TFR) or (thin-film adj resonator\$1) or	<pre>IBM_TDB USPAT;</pre>	2003/11/17 19:08
		(film adj resonator\$1)).ti.	US-PGPUB;	2003/11/1/ 19:08
			EPO; JPO; DERWENT;	
]_	276	(/TED) on (thin 5:13:	IBM_TDB	
	210	((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).ab.	USPĀT; US-PGPUB;	2003/11/17 18:59
			EPO; JPO;	
			DERWENT; IBM TDB	
_	74	((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).clm.	USPĀT;	2003/11/17 18:59
		(222m ad) resonatory;).crm.	US-PGPUB; EPO; JPO;	
			DERWENT;	
-	415	(((TFR) or (thin-film adj resonator\$1) or	IBM_TDB USPAT;	2003/11/17 19:00
		(film adj resonator\$1)).ti.) or (((TFR) or (thin-film adj resonator\$1) or (film adj	US-PGPUB; EPO; JPO;	
		resonator\$1)).ab.) or (((TFR) or	DERWENT;	
		<pre>(thin-film adj resonator\$1) or (film adj resonator\$1)).clm.)</pre>	IBM_TDB	

	526	(film adj resonator\$1)) and ((zinc adj oxide) or (aluminum adj nitride) or AlN or ZnO)) or (((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).ti.) or (((TFR) or (thin-film adj resonator\$1)).ab.) or (((TFR) or (thin-film adj resonator\$1)) or ((film adj resonator\$1)).ab.) or ((film adj resonator\$1)).clm.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/17 19:02
-	496		USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/11/17 19:01
_	723	<pre>(((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)) and ((zinc adj oxide) or (aluminum adj nitride) or AlN or ZnO)) or (((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).ti.) or (((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).ab.) or (((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).clm.) or (((TFR) or (thin-film adj resonator\$1) or (film adj resonator\$1)).dm.) or ((film adj resonator\$1)) and (electrode\$1 or aluminum))</pre>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/17 19:02
	395		USPAT; US-PGPUB	2003/11/17 19:02
_	278		USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/11/17 19:09
_	57	(bulk adj acoustic).ti. and (electrode\$1 with (aluminum or Al))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/11/17 19:09
_	2	("61077344").PN.	JPO; DERWENT	2003/11/19 15:26
~	3817	(etch\$3 and taper\$2).ab.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/11/19 16:35
-	1531	((etch\$3 and taper\$2).ab.) and (mask\$3 or \$5resist) and layer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/11/19 15:34
_	199	((etch\$3 and taper\$2).ab.) and (mask\$3 or \$5resist) and (second adj (layer or film or metal\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/11/19 15:39

_	39	(etch\$3 and taper\$2 and (Ti or titanium)	USPAT;	2003/11/19 16:25
		and (Al or aluminum)).ab.	US-PGPUB;	
			EPO; JPO;	
	}		DERWENT;	
			IBM TDB	
-	1	2002-087381.NRAN.	DERWENT	2003/11/19 15:53
**	673	(etch\$3 and taper\$2 and angle).ab.	USPAT;	2003/11/19 16:30
		-	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
-	53	(etch\$3 and taper\$2 and angle).ab. and (Ti	USPAT;	2003/11/19 16:30
		or titanium)	US-PGPUB;	
	}		EPO; JPO;	
			DERWENT;	
			IBM TDB	
-	144	(etch\$3 and taper\$2).ab. and (al or	USPĀT;	2003/11/19 16:36
		aluminum) and (Ti or titanium) and (mask\$3	US-PGPUB;	
		or \$5resist)	EPO; JPO;	1
			DERWENT;	
			IBM_TDB	